

PATENT

THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application

Parks et al.

Confirmation No.: Not Yet Assigned

Serial No.: 10/751,360

Group Art Unit: Not Yet Assigned

Filed: January 5, 2004

Examiner: Not Yet Assigned

Docket No.: 062020-1380

For: Magnetic Inductor Core and Inductor and Methods for Manufacturing Same

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Sir:

This information disclosure statement is filed in accordance with 37 C.F.R. §§ 1.56, 1.97, and 1.98, and specifically:

under 37 CFR 1.97(b), or
(within Three months of filing national application; or date of entry of international application; or before mailing date of first office action on the merits; whichever occurs last)

under 37 CFR 1.97(c) together with either a:
 Statement Under 37 C.F.R. 1.97(e), or
 a \$180.00 fee under 37 CFR 1.17(p), or
(After the CFR 1.97(b) time period, but before the final office action or notice of allowance, whichever occurs first)

under 37 CFR 1.97(d) together with a:
 Statement under 37 CFR 1.97(e), and
 a \$180.00 petition fee set forth in 37 CFR 1.17(p).
(Filed after final office action or notice of allowance, whichever occurs first, but before payment of the issue fee)

Enclosed is a check in the amount of \$. Please charge \$ to deposit account . At any time during the pendency of this application, please charge any fees required to Deposit Account 20-0778 pursuant to 37 CFR 1.25. The Commissioner is hereby requested to credit any overpayment to Deposit Account No. 20-0778.

Applicant(s) submit herewith *Form PTO 1449A - Information Disclosure Statement by Applicant* together with copies (where required) of patents, publications or other information of which applicant(s) are aware, which applicant(s) believe(s) may or may not be material to the examination of this application and for which there may be a duty to disclose in accordance with 37 CFR 1.56. As required by 37 C.F.R. §1.98(a), a legible copy of each document is provided.

A concise explanation of the relevance of foreign language patents, foreign language publications and other foreign language information listed on PTO Form 1449, as presently understood by the individual(s) designated in 37 CFR 1.56(c) most knowledgeable about the content is given on the attached sheet, or where a foreign language patent is cited in a search report or other action by a foreign patent office in a counterpart foreign application, an English language version of the search report or action which indicates the degree of relevance found by the foreign office is listed on the form PTO 1449 and is enclosed herewith.

The following rights are reserved by the Applicant(s): the right to establish the patentability of the claimed invention over any of the listed documents should they be applied as reference, and/or the right to prove that some of these documents may not be prior art, and/or the right to prove that some of these documents may not be enabling for the teachings they purport to offer.

This statement should not be construed as a representation that an exhaustive search has been made, or that information more material to the examination of the present application does not exist. Any statements or identifications regarding the relevance of any portion(s) of cited references should not be construed as a representation that the most relevant portion(s) have been identified, and the absence of such statements or identifications should not be construed as representations that there are no relevant portion(s). The Examiner is specifically requested not to rely solely on the materials submitted herewith. The Examiner is requested to conduct an independent and thorough review of the documents, and to form independent opinions as to their significance.

It is requested that the information disclosed herein be made of record in this application and that the Examiner initial and return a copy of the enclosed PTO-1449 to indicate the documents have been considered.

Respectfully Submitted,

**THOMAS, KAYDEN, HORSTEMEYER
& RISLEY, L.L.P.**

By:



Scott A. Horstemeyer – Reg. No. 34,183

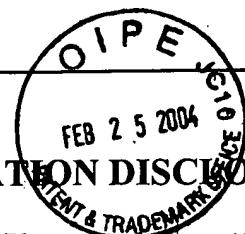
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CERTIFIED MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as "First Class Mail," in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on February 23, 2004

Belinda K. Weiss
Signature

Form PTO-1449



INFORMATION DISCLOSURE CITATION

(Use several sheets if necessary)

Attorney Docket No.
062020-1380Serial No.
10/751,360Applicant
Parks, et al.Filing Date
January 5, 2004Group
Not Yet Assigned

U.S. PATENT DOCUMENTS

Examiner Initials	Item	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
	A						
	B						

FOREIGN PATENT DOCUMENTS

		Document Number	Date	Country	Class	Subclass	Translation	
							Yes	No
	C							
	D							

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)

	E	Jin-Woo Park and Mark G. Allen, Paper entitled "Ultra-Low-Profile Micromachined Power Inductors with Highly Laminated Ni/Fe Cores: Application to Low MHz DC-DC Converters", IEEE Transactions on Magnetics, Vol. 39, No. 5, September, 2003, pp. 3184-3816, 3 pages
	F	Charles R. Sullivan and Seth R. Sanders, Paper entitled "Microfabrication of Transformers and Inductors for High Frequency Power Conversion", 1993 IEEE, pp. 33-41, 9 pages.
	G	Charles R. Sullivan and Seth R. Sanders, Paper entitled "Microfabrication Process for High-Frequency Power-Conversion Transformers", 1995 IEEE, pp 658-664, 7 pages.
	H	Ming Xu, Trifon M. Liakopoulos and Chong H. Ahn, Paper entitled "A Microfabricated Transformer for High-Frequency Power or Signal Conversion", IEEE Transactions on Magnetics, Vol. 34, No. 4, July, 1998, pp. 1369-1371, 3 pages.
	I	Jae Yeong Park, Suk H. Han, and Mark G. Allen, Paper entitled "Batch-Fabricated Microinductors with Electroplated Magnetically Anisotropic and Laminated Alloy Cores", IEEE Transactions on Magnetics, Vol. 35, No. 5, September 1999, pp. 4291-4300, 10 pages
	J	Jin-Woo Park, Jae Yeong Park, Yeun-Ho Joung and Mark G. Allen, Paper entitled "Fabrication of High Current and Low Profile Micromachined Inductor With Laminated Ni/Fe Core", IEEE Transactions on Components and Packaging Technologies, Vol. 25, No. 1, March 2002, pp. 106-111, 6 pages.
	K	Jin-Woo Park, Florent Cros and Mark G. Allen, Paper entitled "A Sacrificial Layer Approach to Highly Laminated Magnetic Cores", 4 pages.
	L	Steven D. Leith and Daniel T. Schwartz, Paper entitled "In-situ Fabrication of Sacrificial Layers in Electrodeposited NiFe Microstructures", J. Micromech. Microeng. 9 (1999). Printed in the United Kingdom, pp. 97-104, 8 pages.
	M	Chun-Chen Yang and Huk Y. Cheh, Paper entitled "Pulsed Electrodeposition of Copper/Nickel Multilayers on a Rotating Disk Electrode", J. Electrochem. Soc., Vol. 142, No. 9, September, 1995, pp. 3034-3043, 10 pages.

* EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.

EXAMINER'S SIGNATURE:

DATE CONSIDERED: